

SEP-20-2007 THU 12:10 PM TROP, PRUNER & HU, PC

FAX NO. 7134688883

P. 02

RECEIVED
CENTRAL FAX CENTER

SEP 20 2007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:	§	Art Unit:	2814
Ilya Karpov et al.	§		
	§	Examiner:	Long Pham
Serial No.: 10/822,361	§		
	§	Docket:	ITL.0835D1US
Filed: April 12, 2004	§		P14730D
	§		
For: Fabricating Deeper and	§	Assignee:	Intel Corporation
Shallower Trenches in	§		
Semiconductor Structures	§	Conf. No.	3077

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

REPLY TO FINAL REJECTION

Sir:

In response to the final rejection mailed August 15, 2007, please amend the above-referenced patent application as follows:

Date of Deposit: September 20, 2007
I hereby certify that this document is being facsimile transmitted to the United States Patent and Trademark Office (Fax No. 571/273-8300) on the date indicated above.
Cynthia L. Hayden
Cynthia L. Hayden